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Examiner

Kennedy Schaetzle

Applicant(s)/Patent	unde
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KRAMER ET AL.

Art Unit

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SEARCHED			
Class	Subclass	Date	Examiner
607	009 014 015 022 024 025 027	6/22/2006	KJS
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH	ES STRATEGY	)
	DATE	EXMR
EAST search (see addendum) Inventor name search	6/22/2006	KJS